

Transmission Electron Microscopy: An Introduction

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Textbooks

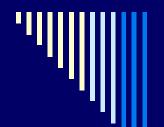
- □ David B. Williams & Barry C. Carter "Transmission electron microscopy", Volumes I-IV, Plenum Press, New York, 1996
- Marc De Graef, "Introduction to Conventional Transmission Electron Microscopy", Cambridge University Press, 2003.
- □ See also: http://www.matter.org.uk/tem/default.htm



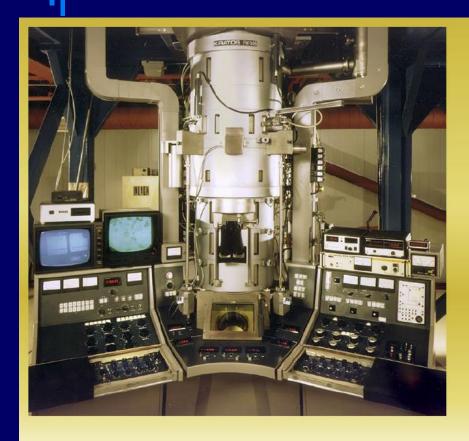
An extremely brief history

- 1925, Louis de Broglie: wave-like characteristics of electrons with λ substantially less than visible light
- 1927, Thompson and Reid: Diffraction experiments
- 1932, Knoll and Ruska (1986 Nobel Prize): Electron lenses idea!
 Demonstration of electron images!
- 1936: First commercial TEM instrument
- □ 1939: Siemens & Halske: regular production

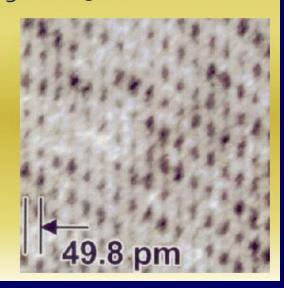




Extreme TEM instruments

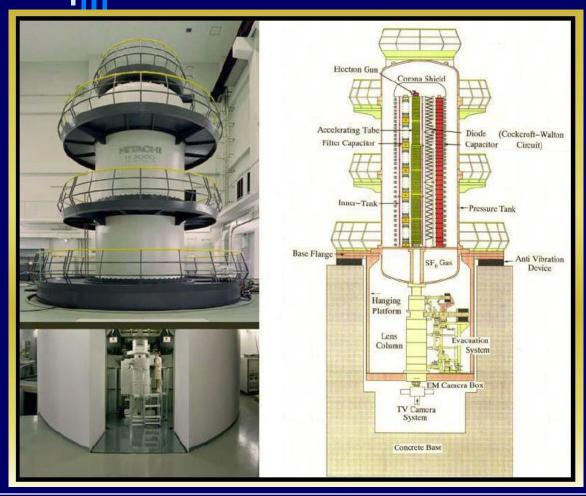


A 1-MeV TEM coupled with a field emission source can achieve resolutions that are in the range of 0.5Å!

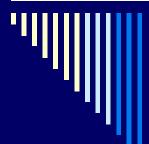




Extreme TEM instruments



A 3 MeV TEM by Hitachi



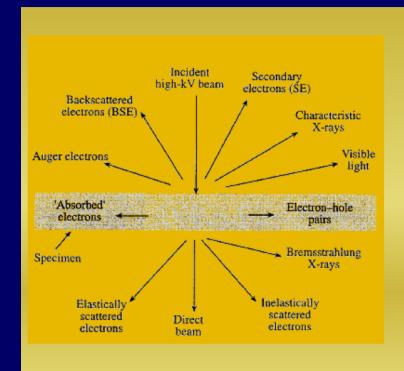
Regular HR-TEM instruments

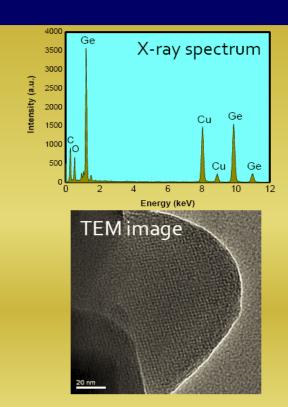






Interaction of an electron beam with matter



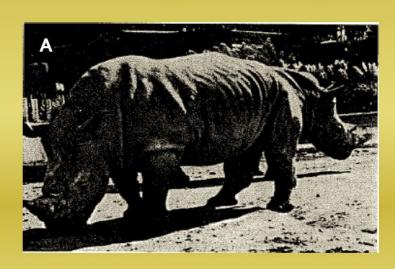


- To get the best signal out we have to put the best signal in (electron source)
- Today TEM form very fine electron beams < 10 nm even < 1 nm in diameter (STEM)



Drawbacks and limitations

- Limited in a very small area of sample, till now ≈ 1 mm² of materials are have been examined!
- Presents 2D images of real 3D specimens, Fig. A

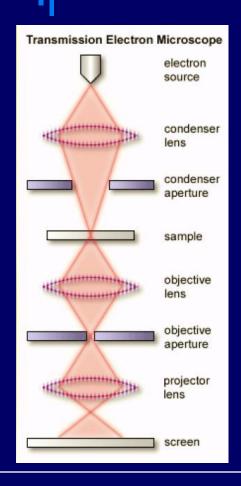


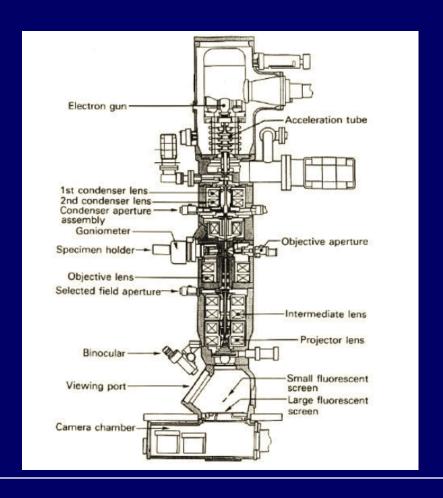


- ✗ Beam damage (up to 400 kV), Fig. B
- ★ Thin "electron transpared" specimens are needed for HRTEM (usually a sample thickness < 50 nm is essentially)</p>



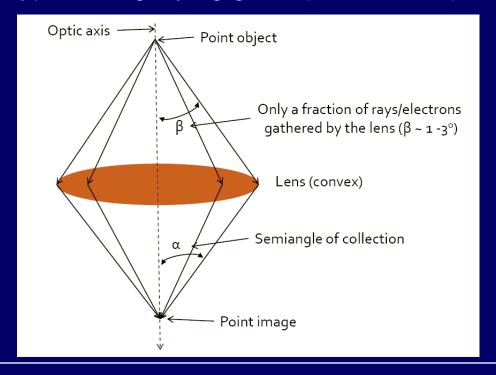
TEM Anatomy



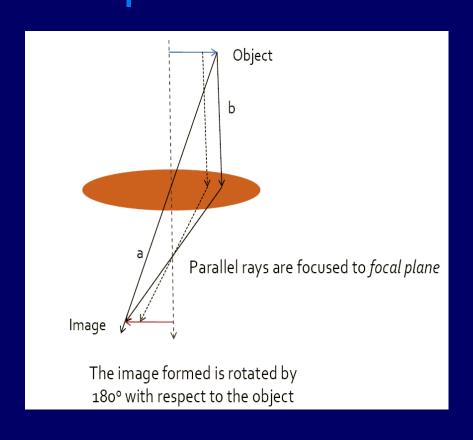


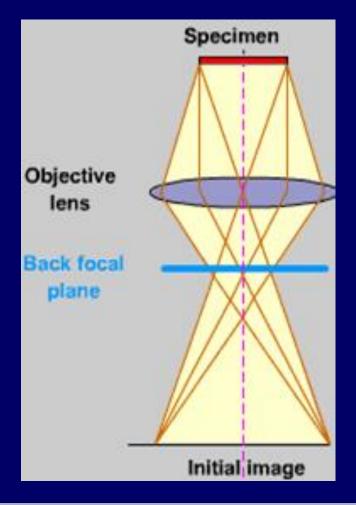


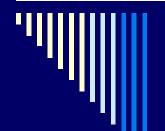
- The lenses are considered the HEART of the TEM.
- We are talking about magnetic lenses, but you may consider these operating as typical magnifying glass (convex lens).











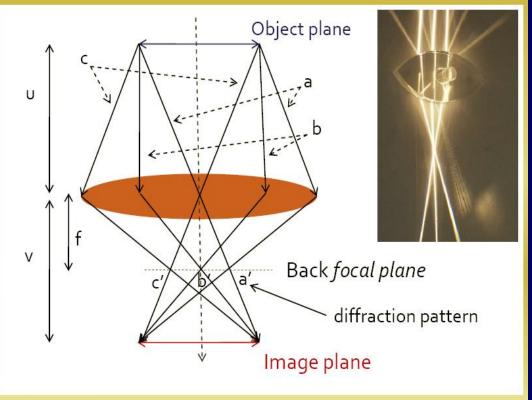
In perfect lenses:

$$\frac{1}{f} = \frac{1}{u} + \frac{1}{v}$$

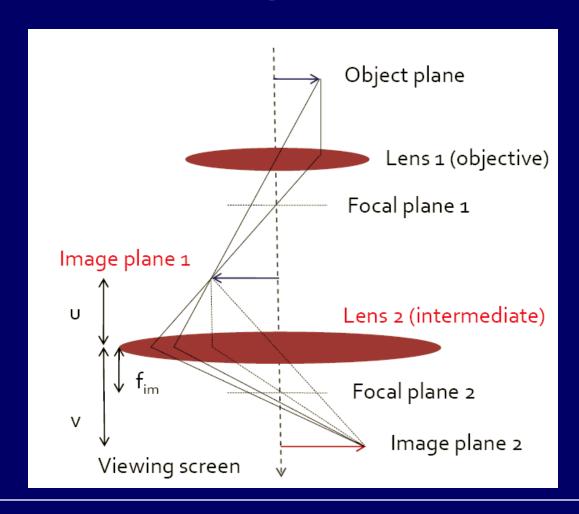
"lens formula"

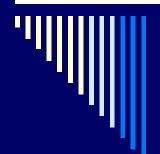
$$M = v/u$$

- •if u=f, then v=∞
- •if u=v, then u=v=2f
- •if u<f, no real image can form









Magnification in TEM

The total magnification in the TEM is a combination of the magnification from the *objective lens* times the magnification of the *intermediate lens* times the magnification of the *projector lens*.

Total Mag. =
$$M_{ob} \times M_{int} \times M_{proj}$$

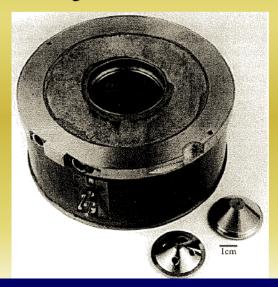
$$(M_{ob} = 50, M_{int} = 16, M_{proj} = 250; M_{total} = 200.000)$$

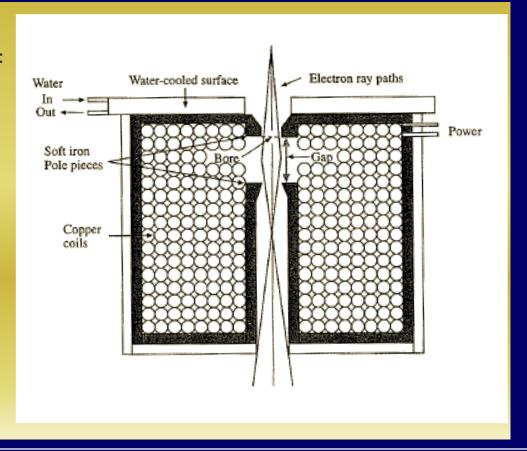


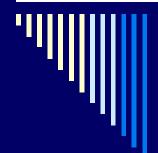
A example of a real lens

Characteristics of electron lens:

- Length of the lens
- The bore/gap ratio
- Strength of the field/current







Further reading......

- A proper alignment is very important before any TEM work is to be conducted.
- Sample preparation for TEM work is of paramount importance. Different samples require very different preparation procedures.
- Remember: TEM is a versatile, integrated instrument suitable for *imaging*, *diffraction* and spectroscopy studies at the atomic scale.